UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.		
10/567,026	01/10/2007	Stephan T. Melnychuk	12435	9466		
=	7590 09/25/200 TT, MURPHY & PRE	EXAMINER				
400 GARDEN		KIKNADZE, IRAKLI				
SUITE 300 GARDEN CIT	Y, NY 11530	ART UNIT	PAPER NUMBER			
			2882			
		MAIL DATE	DELIVERY MODE			
			09/25/2008	PAPER		

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

		Application	oplication No. Applicant(s)					
Office Action Summary			10/567,026	3	MELNYCHUK ET AL.			
			Examiner		Art Unit			
			IRAKLI KIK	NADZE	2882			
Period fo	The MAILING DATE of this commun or Reply	nication appe	ears on the	cover sheet with the	correspondence ad	ddress		
WHIC - Exter after - If NC - Failu Any (ORTENED STATUTORY PERIOD FOR CHEVER IS LONGER, FROM THE IN THE INSTRUCTION OF THE INSTRUC	MAILING DA s of 37 CFR 1.136 munication. tatutory period wi y will, by statute, o	TE OF THI 6(a). In no ever ill apply and will cause the applic	S COMMUNICATIO it, however, may a reply be til expire SIX (6) MONTHS from ation to become ABANDONE	N. mely filed the mailing date of this of the (35 U.S.C. § 133).	·		
Status								
1) 又	Responsive to communication(s) file	ed on <i>2/2/06</i>	3					
'=	•	2b)⊠ This a	_	n-final				
3)		<i>-</i> —			nsecution as to th	a marite is		
3/1	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
	closed in accordance with the pract	ice dilaci Z	n parie Que	y/c, 1555 O.D. 11, 4	00 0.0. 210.			
Dispositi	on of Claims							
4)🛛	Claim(s) 1-27 is/are pending in the	application.						
	4a) Of the above claim(s) is/a	are withdraw	n from con	sideration.				
5)🛛	☑ Claim(s) <u>18-21,25 and 26</u> is/are allowed.							
6)🖂								
· · · · ·	Claim(s) 9,12 and 13 is/are objected	·=						
	Claim(s) are subject to restri		election re	quirement.				
Applicati	on Papers							
	The specification is objected to by the	o Evaminar						
•	•			ontod or b\□ objecte	nd to by the Even	inor		
10)[10)☑ The drawing(s) filed on <u>02 February 2006</u> is/are: a)☑ accepted or b)☐ objected to by the Examiner. Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
				-		SED 4 404/4)		
441	Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11)	11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.							
Priority ι	ınder 35 U.S.C. § 119							
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 								
2) Notic 3) Inform	t(s) e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (Ination Disclosure Statement(s) (PTO/SB/08) r No(s)/Mail Date 6/6/2008.			4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal R 6) Other:	ate			

Application/Control Number: 10/567,026 Page 2

Art Unit: 2882

DETAILED ACTION

Claim Objections

Claims 3 and 4 are objected to because of the following informalities:
 Claim 3 depends on claim 4 and claim 4 depends on itself.

Appropriate correction is required.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35
 U.S.C. 102 that form the basis for the rejections under this section made in this
 Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 3. Claims 1-8, 10, 11 and 14-17 are rejected under 35 U.S.C. 102(b) as being anticipated by Meilinas et al. (US Patent 6,215,851 B1).

With respect to claims 1 and 8, Meilunas teaches a proton beam target for generating gamma rays in response to an impinging proton beam, the proton beam target comprising: a thin ¹³C Diamond gamma reaction layer (20) for generating the gamma rays therefrom; and a stopping layer (22) for mitigating transmission of the proton beam therethrough, the stopping layer (22) being formed of a refractory metal which has a relatively high hydrogen solubility for

Application/Control Number: 10/567,026

Art Unit: 2882

dissolving implanted hydrogen atoms therewithin as a result of the impingement of the proton beam and which is chemically reactive with the ¹³C Diamond gamma reaction layer for chemically bonding therewith, wherein thermal dissipation in the target under proton beam exposure is improved (column 3, line 49 - column 4, 22 and column 5, lines 1-37).

With respect to claim 2, Meilunas teaches that the refractory metal is Tantalum (Ta) (column 4, line 1).

With respect to claim 3, Meilunas teaches that a braze alloy has a liquidus above 800°C (column 5, lines 4-10).

With respect to claims 4, 5, 10 and 11, Meilunas teaches that the thin ¹³C Diamond gamma reaction layer is deposited on the stopping layer (22) via a plasma assisted CVD process at a temperature below said braze alloy liquidus (column 4, lines 42-54).

With respect to claim 14, Meilunas teaches that the stopping layer comprises a metal foil brazed to a surface of a cooling support fabricated from a low z, high thermal conductivity material. The cooling support dissipates heat energy away from the stopping layer, said stopping layer being attached to the cooling support and is interposed between the ¹³C Diamond gamma reaction layer and the cooling support (column 4, lines 60-67).

With respect to claims 6 and 7, Meilunas teaches a method of fabricating a proton beam target for generating gamma rays that are reflected therefrom in response to an impinging proton beam, the method comprising the steps of: (a) forming a stopping layer (22) of a refractory metal for mitigating transmission of

Art Unit: 2882

the proton beam therethrough, the stopping layer (22) having a relatively high hydrogen solubility for dissolving implanted hydrogen atoms therewithin as a result of the impingement of the proton bean; and (b) attaching a thin ¹³C Diamond gamma reaction layer to the stopping layer for generating the gamma rays therefrom in response to the impinging proton beam, the stopping layer (22) being chemically reactive with the ¹³C Diamond (column 3, line 49 - column 4, 22 and column 5, lines 1-37).

With respect to claim 15, Meilunas teaches that the thin ¹³C Diamond gamma reaction layer is attached to the stopping layer via plasma assisted CVD process (column 4, lines 42-54).

With respect to claim 16, Meilunas teaches attaching the stopping layer (22) onto a cooling support for dissipating heat energy away from the stopping layer column 4, lines 60-67).

With respect to claim 17, Meilunas teaches that the stopping layer (22) is attached to the cooling support via brazing (column 5, lines 4-15).

Claim Rejections - 35 USC § 103

4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Application/Control Number: 10/567,026

Art Unit: 2882

Claims 22-24 and 27 are rejected under 35 U.S.C. 103(a) as being unpatentable over Sredniawski (US Patent 5,784,430) in view of Meilunas et al. (US Patent 6,215,851 B1).

With respect to claim 22, Sredniawski teaches a contraband detection system comprising: a means for producing a high energy beam of protons (10) at a specific energy with a very narrow energy spread; a proton beam target (12) for generating gamma rays (14) in response to impinging high energy beam of protons, the resultant gamma rays (14) being preferentially absorbed by a targeted contraband material (18); and, a plurality of detector means (22) for detecting absorption of the gamma rays indicating presence of the targeted contraband material, wherein the proton beam target comprises: a thin ¹³C Diamond gamma reaction layer for generating the gamma rays therefrom (column 4, lines 40-63). Sredniawski is silent about a stopping layer. Meilunas teaches a means for producing a high energy beam of protons at a specific energy with a very narrow energy spread; a proton beam target (18) for generating gamma rays in response to impinging high energy beam of protons, a stopping layer (22), such as Tantalum (Ta), for mitigating transmission of the proton beam therethrough, the stopping layer being formed of a refractory metal which has a relatively high hydrogen solubility for dissolving implanted hydrogen atoms therewithin as a result of the impingement of the proton beam and which is chemically reactive with the ¹³C Diamond gamma reaction layer for chemically bonding therewith, wherein thermal dissipation in the target under proton beam exposure is improved (column 3, lines 49-65 and colum 4, lines 23-58). Ta metal

Application/Control Number: 10/567,026 Page 6

Art Unit: 2882

has a high solubility limit for hydrogen which allowes a high dose of protons to be implanted into the Ta stopping layer before target blistering occurs. The carbide forming nature of Ta contributes good adhesion between the Ta stopping layer and ¹³C diamond (column 4, lines 43-58). It would have been obvious to one of ordinary skill in the art at the time the invention was made to employ the stopping layer teachings of Meilunas in the meted of Sredniawski because it would provide improved proton beam target device for contraband detection system.

With respect to claim 23, Sredniawski teaches that the means for producing a high-energy beam of protons comprises a high current electrostatic accelerator (column 5, lines 40-45).

With respect to claim 24, Sredniawski teaches that the detector means (22) for detecting absorption of said gamma rays comprises Bismuth Germinate (BGO) scintillator detectors (column 6, lines 36-44).

With respect to claim 27, Sredniawski teaches that the detector means for detecting absorption of said gamma rays comprises nitrogenous liquid scintillator detectors (column 5, lines 1-3).

Allowable Subject Matter

- 5. Claims 9, 12 and 13 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
 - 6. Claims 18-21, 25 and 26 are allowed.

Application/Control Number: 10/567,026 Page 7

Art Unit: 2882

7. The following is a statement of reasons for the indication of allowable subject matter: With respect to claims 9, 12, 13, 18-21, 25 and 26 prior art does not teach or fairly suggest a proton beam target, method of fabricating a proton beam target and contraband detection system comprising: generating gamma rays in response to an impinging proton beam comprising a stopping layer comprising a SiC substrate as claimed including all of the limitations of the base claim and any intervening claims.

Conclusion

8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to IRAKLI KIKNADZE whose telephone number is (571)272-2493. The examiner can normally be reached on 9:00-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Ed Glick can be reached on 571-272-2490. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Art Unit: 2882

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Irakli Kiknadze

/Irakli Kiknadze/

Primary Examiner, Art Unit 2882

/I. K./ September 23, 2008